Docket No. 214144US8

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Naoki TSUKIJI, et al.

SERIAL NO: 10/014,507

GAU: 2813

RCE FILED: HEREWITH

EXAMINER: SCHILLINGER, LAURA M.

FOR:

METHOD OF MANUFACTURING SEMICONDUCTOR ELEMENT, AND SEMICONDUCTOR

ELEMENT MANUFACTURED WITH THIS METHOD

## REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a one month extension of time be granted to July 25, 2004 for

filing a response to the Official Action dated: March 25, 2004
ining a response to the Official retion dated. March 25, 2001
responding to the requirements in the Notice of Allowability dated:
filing the Formal Drawings. The Issue Fee due has been timely filed.
responding to the Notice to File Missing Parts of Application dated:
filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
filing an Appeal Brief. A Notice of Appeal was filed on:
Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$110.00 is enclosed herewith by credit card payment and any further charges may be made against the Attorney of Record's Deposit Account No. <u>15-0030</u>. A duplicate copy of this sheet is enclosed.

07/27/2004 SDIRETA1 00000103 10014507

02 FC:1251

110.00 OP

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,

MAIER & NEUSTADT, P.C.

**Customer Number** 

22850

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 05/03) Bradley D. Lytle

Registration No. 40,073

Edwin D. Garlepp

Registration No. 45,330

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